



**ELECTRONIC COPY**

LG757537350  
Report verification at igi.org



December 17, 2025  
IGI Report Number **LG757537350**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **SQUARE CUSHION MODIFIED BRILLIANT**  
Measurements **9.36 X 9.21 X 6.10 MM**  
**GRADING RESULTS**  
Carat Weight **4.04 CARATS**  
Color Grade **D**  
Clarity Grade **VS 1**

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**GRADING RESULTS**

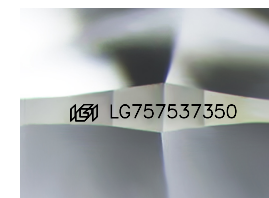
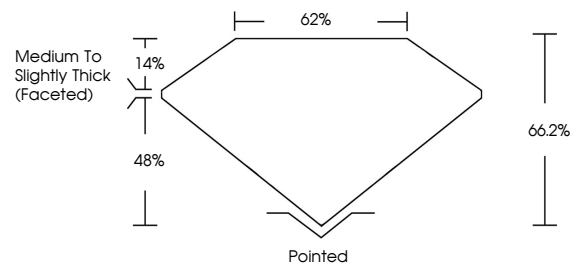
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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG757537350**

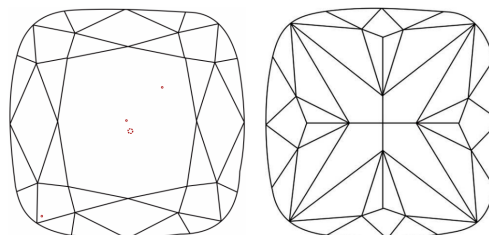
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

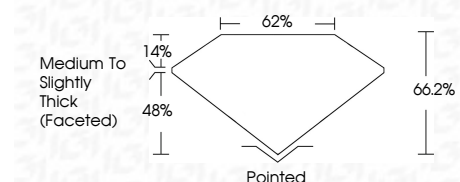
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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**SQUARE CUSHION MODIFIED BRILLIANT**  
9.36 X 9.21 X 6.10 MM  
4.04 CARATS  
D  
4.04 CARATS  
D  
VS 1  
66.2%  
62%  
Medium to Slightly Thick (Faceted)  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG757537350  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa